



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Hideki KOMATSUDA et al.

Group Art Unit: 2882

Application No.: 09/396,582

Examiner: C. Church

Filed: September 15, 1999

Docket No.: 105203

For: EXPOSURE APPARATUS AND EXPOSURE METHOD USING SAME

AMENDMENT

RECEIVED

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

MAR 0 8 2004

Sir:

In reply to the November 5, 2003 Office Action, the shortened statutory period for reply being extended by the attached Petition for Extension of Time, please consider the following:

Amendments to the Claims as reflected in the listing of claims; and

Remarks.